

10/593556
IAP9/Rec'd PCT/PTO 20 SEP 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Michitaka OHTAKI**

Application Number: **Not yet assigned**
(§371 of international application No. PCT/JP2005/005088)

Filed: **September 20, 2006**

For: **POROUS THERMOELECTRIC MATERIAL AND PROCESS FOR
PRODUCING THE SAME**

Attorney Docket Number: **062925**
Customer Number: **38834**

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 20, 2006

Sir:
Prior to calculation of the filing fee and examination of this application, please
amend the above-identified application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.